

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Hajime KANAZAWA, et al.

Group Art Unit: 2884

Serial No.: 10/808,657

Examiner: Shun K. Lee

Filed: March 25, 2004

For: APPARATUS AND METHOD FOR MEASURING EUV LIGHT INTENSITY  
DISTRIBUTION

**AMENDMENT**

Mail Stop - **RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please enter this Amendment in the above-identified application before continued examination on the merits. A Request for Continued Examination (RCE) is being filed concurrently herewith. This Amendment and accompanied RCE have been filed in response to the final Office Action mailed September 8, 2006. Entry and reconsideration are respectfully requested.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.